

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE UNITED STAIL.

In re the Application of: HATTORI, Kazuhiro RECE/VE/

AUG 12 2003

TC 1700

Group Art Unit: 1765

Examiner: Lan Vinh

P.T.O. Confirmation No.: 5542

DRY ETCHING METHOD, MICROFABRICATION PROCESS AND DRY For. **ETCHING MASK**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Date: August 8, 2003

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated April 8, 2003 for one month from July 8, 2003 to August 8, 2003.

Attached please find a check in the amount of \$110.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

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110.00 ARMSTRONG, WESTERMAN & HATTORI, LLP

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PATENT TRADEMARK OFFICE